
This is an electronic reprint of the original article.

This reprint may differ from the original in pagination and typographic detail.

Xue, Hui; Dai, Yunyun; Kim, Wonjae; Wang, Yadong; Bai, Xueyin; Qi, Mei; Halonen, Kari; Lipsanen, Harri; Sun, Zhipei

High photoresponsivity and broadband photodetection with a band-engineered $\text{WSe}_2/\text{SnSe}_2$ heterostructure

Published in:
Nanoscale

DOI:
[10.1039/c8nr09248f](https://doi.org/10.1039/c8nr09248f)

Published: 21/02/2019

Document Version
Publisher's PDF, also known as Version of record

Published under the following license:
CC BY-NC

Please cite the original version:
Xue, H., Dai, Y., Kim, W., Wang, Y., Bai, X., Qi, M., Halonen, K., Lipsanen, H., & Sun, Z. (2019). High photoresponsivity and broadband photodetection with a band-engineered $\text{WSe}_2/\text{SnSe}_2$ heterostructure. *Nanoscale*, 11(7), 3240-3247. <https://doi.org/10.1039/c8nr09248f>



Cite this: *Nanoscale*, 2019, **11**, 3240

High photoresponsivity and broadband photodetection with a band-engineered WSe₂/SnSe₂ heterostructure†

Hui Xue,^a Yunyun Dai,^a Wonjae Kim,^b Yadong Wang,^a Xueyin Bai,^a Mei Qi,^{a,c} Kari Halonen,^a Harri Lipsanen^a and Zhipei Sun^{a,d}

van der Waals (vdW) heterostructures formed by stacking different two-dimensional layered materials have been demonstrated as a promising platform for next-generation photonic and optoelectronic devices due to their tailorable band-engineering properties. Here, we report a high photoresponsivity and broadband photodetector based on a WSe₂/SnSe₂ heterostructure. By properly biasing the heterostructure, its band structure changes from near-broken band alignment to type-III band alignment which enables high photoresponsivity from visible to telecommunication wavelengths. The highest photoresponsivity and detectivity at 532 nm are $\sim 588 \text{ A W}^{-1}$ and 4.4×10^{10} Jones and those at 1550 nm are $\sim 80 \text{ A W}^{-1}$ and 1.4×10^{10} Jones, which are superior to those of the current state-of-the-art layered transition metal dichalcogenides based photodetectors under similar measurement conditions. Our work not only provides a new method for designing high-performance broadband photodetectors but also enables a deep understanding of the band engineering technology in the vdW heterostructures possible for other applications, such as modulators and lasers.

Received 15th November 2018,

Accepted 21st January 2019

DOI: 10.1039/c8nr09248f

rsc.li/nanoscale

Introduction

Recently, two-dimensional (2D) layered materials have received significant attention for photodetection applications due to their high optical absorption,^{1–10} high carrier mobility and good flexibility.^{11–16} For example, semiconducting transition metal dichalcogenides (TMDs, such as MoS₂, WSe₂, MoS₂ and MoSe₂) are considered as promising candidates for future photodetection applications.¹⁷ Indeed, photodetectors with TMDs have been demonstrated with high photoresponsivity (e.g., 800 A W^{-1} at 561 nm with monolayer MoS₂).¹⁸ However, the previously reported operation bandwidth of a TMD-based photodetector is typically limited by the bandgap of the TMD

material. For example, the bandgap of MoS₂ is between ~ 1.2 eV (bulk) and ~ 1.8 eV (monolayer).^{19,20} Therefore, in principle, a MoS₂ based photodetector typically cannot effectively detect light with a photon energy smaller than 1.2 eV. Such an intrinsic bandgap limitation poses a great challenge for various photonic applications (e.g., telecommunications).

van der Waals (vdW) heterojunctions, formed by stacking different individual 2D layered materials, can offer a new dimension in breaking the abovementioned intrinsic bandgap barrier.^{21–31} In general, three types of band alignments can be categorized when different 2D materials are stacked together,³² including type-I,³³ type-II,^{34–38} and type-III^{39–43} band alignments. Thus far, most of the reported vdW heterostructure photodetectors are based on the type-II band alignment to utilize the excellent electron–hole pair separation ability in heterostructures. Recently, type-III band alignment has been explored as a platform for tunneling field effect transistors (TFETs) due to its enhanced tunneling current density.^{40,44–49} The 2D layered materials based type-III band alignment TFETs with improved responsivity and detectivity have been the focus of many recent studies in the visible wavelengths (e.g. 5.7 A W^{-1} under 660 nm,⁵⁰ 244 A W^{-1} under 550 nm,⁵¹ 180 A W^{-1} under 405 nm⁴⁷). However, the applications of the type-III band alignment TFETs in the field of broadband photodetection have rarely been reported. In this paper, we report a high photoresponsivity and broadband photodetector based on a WSe₂/SnSe₂ heterostructure. By applying a large negative

^aDepartment of Electronics and Nanoengineering, Aalto University, Espoo 02150, Finland. E-mail: hui.xue@aalto.fi

^bVTT Technical Research Center of Finland, Espoo 02150, Finland

^cNanobiophotonic Center, State Key Lab Incubation Base of Photoelectric Technology and Functional Materials, International Cooperation Base of Photoelectric Technology and Functional Materials, and Institute of Photonics & Photon-Technology, Northwest University, Xi'an 710069, China

^dQTF Centre of Excellence, Department of Applied Physics, Aalto University, FI-00076 Aalto, Finland

†Electronic supplementary information (ESI) available: (1) AFM image of a heterostructure, (2) Raman spectra of the heterostructure, (3) electrical characteristics of WSe₂ and SnSe₂ based FETs, (4) photoresponsivity comparison of this work and previous results, (5) photo-switching characteristics of the device. See DOI: 10.1039/c8nr09248f



gate voltage and a reverse bias voltage, the heterojunction band structure changes from type-II to type-III band alignment and a band-to-band tunneling phenomenon occurs. The increased band bending at the heterojunction results in the tunneling-assisted transition which possibly allows photocurrent generation with energy smaller than the bandgap of WSe₂ (e.g., 980 nm and 1550 nm) for broadband photodetection (e.g. photo-excited electron tunnel from WSe₂ to the conduction band of SnSe₂). Under the type-III band alignment conditions, our heterojunction device shows a high photo-responsivity up to $\sim 588 \text{ A W}^{-1}$ at a wavelength of 532 nm and $\sim 80 \text{ A W}^{-1}$ at a wavelength of 1550 nm. The corresponding photodetectivity reaches 4.4×10^{10} Jones and 1.4×10^{10} Jones for visible and telecommunication wavelengths, respectively.

Results and discussion

The optical image and schematic illustration of the WSe₂/SnSe₂ heterostructure device are shown in Fig. 1a. Few-layer p-type WSe₂ and n-type SnSe₂ flakes, mechanically exfoliated from their bulk materials, are transferred onto a 280 nm SiO₂/silicon substrate. An overlapping heterojunction region is formed by precisely controlling their locations. Pd/Au metal contacts (20/50 nm) are patterned onto the WSe₂ and SnSe₂ flakes to collect holes and electrons. The thicknesses of the

WSe₂ and SnSe₂ few-layer flakes are determined by atomic force microscopy (AFM), giving the values of 6 nm and 15 nm, respectively (ESI Fig. S1†). Raman spectroscopy is employed to confirm the high quality of our device after the fabrication processes (ESI Fig. S2†).

Before testing the electrical characteristics of the WSe₂/SnSe₂ heterostructure, we also fabricated two individual WSe₂ and SnSe₂ based field effect transistors (FETs) to analyze the properties of WSe₂ and SnSe₂. WSe₂ and SnSe₂ FETs are fabricated on Si/SiO₂ substrates with Pd/Au (20/50 nm) as the drain and source electrodes. The transfer curves of the FETs (ESI Fig. S3†) show p-type characteristics for WSe₂ and n-type characteristics for SnSe₂, indicating that Pd can efficiently inject holes into WSe₂ and electrons into SnSe₂ when a negative gate voltage is applied.^{41,52} Moreover, the nonlinear output results of the WSe₂ flake (ESI Fig. S3b†) indicate the existence of a Schottky barrier at the contact region, while the SnSe₂ results (ESI Fig. S3d†) indicate that an ohmic contact is formed between Pd and SnSe₂. Note that, since SnSe₂ is a degenerated n-doped semiconductor, the band alignment of SnSe₂ at the interface would be relatively unaffected by the V_g (see ESI Fig. S3c†).^{35,43}

Next, the electronic properties of the WSe₂/SnSe₂ heterojunction is studied. The device is characterized by applying a constant drain to source voltage (V_d) and a gate voltage (V_g) in the configuration shown in Fig. 1a. The device shows obvious p-type transport characteristics. The concentration and the

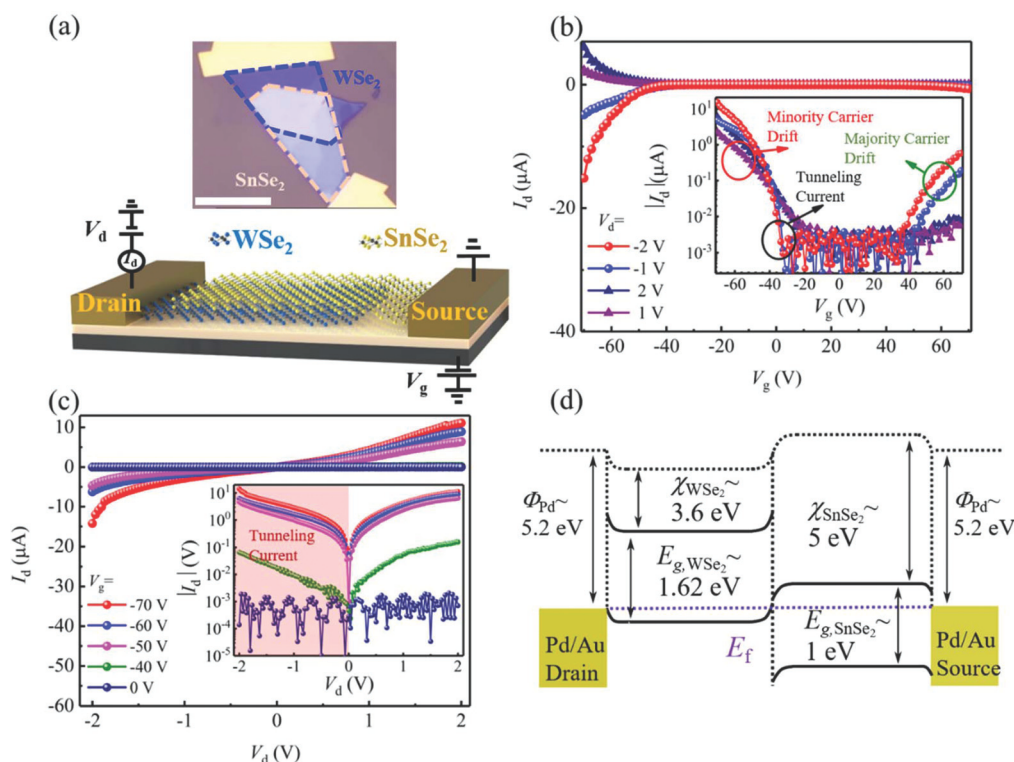


Fig. 1 The WSe₂/SnSe₂ heterostructure device and its electronic properties. (a) Microscopy image (upper panel) and schematic illustration (bottom panel) of the heterojunction device. (b) I_d – V_g characteristics measured with variable V_d in the dark. Inset: $|I_d|$ – V_g characteristics on the logarithmic scale. (c) I_d – V_d characteristics measured with variable V_g in the dark. Inset: $|I_d|$ – V_d characteristics on the logarithmic scale. (d) The schematic band diagrams of the heterojunction. The scale bar is 10 μm.



type of the carriers can be tuned by V_g , at $V_d = -2$ V; the I_d - V_g result shows the gate-controlled current, with an on-off ratio of $\sim 10^4$ (see Fig. 1b). The reverse current (I_{reverse} , $V_d < 0$ V) at $V_g < -30$ V is the band-to-band tunneling (BTBT) current, whose magnitude increases as the gate voltage decreases. The magnitude of I_{reverse} at $V_g > 40$ V increases as the gate voltage increases due to the majority carrier drifting. The forward current (I_{forward} , $V_d > 0$ V) observed at $V_g < -30$ V can be attributed to the drifting of the minority carriers (see the discussion below). The magnitude of the reverse current increases with both positive and negative V_g and the maximum of the reverse current is 15 μA when $V_d = -2$ V and $V_g = -70$ V. The gate-dependent current-voltage (I_d - V_d) characteristics are shown in Fig. 1c, where two important features can be observed. First, owing to the ultrathin thickness nature of the heterojunction, the magnitude of both I_{forward} and I_{reverse} can be significantly controlled by modifying the gate voltage. Second, since the breakdown voltage (*i.e.* -0.01 V) is very much less than $4E_g/q$, where E_g is the band gap of the semiconductors (1.62 eV of WSe_2 and 1 eV of SnSe_2) and q is the electron charge, the tunneling current (red region in the inset of Fig. 1c) can be attributed to Zener tunneling.⁵³

The qualitative band alignment of the $\text{WSe}_2/\text{SnSe}_2$ heterostructure at zero bias is sketched in Fig. 1d based on the reported electron affinity values in the literature.^{54,55} Based on these values, a nearly broken band alignment is formed, where the Fermi level of WSe_2 locates at the edge of its valence band and that of SnSe_2 locates at the edge of its conduction band. The heterostructure resembles a p-n diode with a staggered band gap offset. The bottom of the conduction band and the top of the valence band of WSe_2 (SnSe_2) are at 3.6 eV (5.22 eV) and 5 eV (6 eV), so that the offsets of the conduction band and valence band are about 1.4 eV and 0.78 eV, respectively.

The transfer characteristics of the heterostructure can be understood through band diagrams (Fig. 2a-c). When there is no gate voltage (*i.e.* $V_g = 0$ V), as shown in Fig. 2(a), the high Schottky barrier at the drain contact and the high difference of the conduction/valence band discontinuity restrain the current flow, leading to the zero dark current. Under these conditions, the device can be seen as a Schottky diode in series with a p-n junction and a resistor. When a negative gate voltage is applied (*i.e.* $V_g < -30$ V) as shown in ESI Fig. S3b,[†] the doping level of WSe_2 is increased and a near-ohmic contact is formed at the drain contact (the band bending direction at the drain contact shifts downwards). Thus, the model of the device under these conditions can be described as two resistors in series with a p⁺n junction. Therefore, when a reverse bias is applied (Fig. 2b), the valence band maximum of WSe_2 shifts above the conduction band minimum of SnSe_2 , and the type of the band structure changes from near broken band alignment to broken band alignment (type-III). Thus, the electrons in the valence band of WSe_2 can tunnel into the conduction band of the SnSe_2 flake. This tunneling current can then be increased by increasing the reverse bias voltage, see Fig. 1c, due to the enlarged overlapping energy level between the valence band of WSe_2 and the conduction band of SnSe_2 .

However, when a forward bias is applied (Fig. 2c), the band alignment changes from type-III to type-II, the barrier height at the heterojunction is reduced, and the majority carriers (electrons in SnSe_2 and holes in WSe_2) can overcome the interface barrier and drift to their counterparts, leading to a high forward current. The carrier transportation under the forward bias conditions follows the mechanism as described for the traditional p-n diode, where the forward current increases exponentially with forward bias.⁴⁰ To further analyze the transfer characteristics of the heterostructure, scanning photocurrent mapping at $\lambda = 532$ nm under a confocal optical microscope (objective 100 \times , NA = 0.75, $P_{\text{laser}} = 50$ μW (corresponding to a power intensity of 8.5×10^3 W cm^{-2})) was performed, as shown in Fig. 2d-f. The spot size (~ 0.6 μm^2 at 532 nm) of the incident laser is much smaller than the size (~ 50 μm^2) of the heterojunction. When there is no bias (*i.e.* $V_g = V_d = 0$ V), as mentioned above, the heterostructure resembles a p-n junction. Thus, when there is an external light excitation, electron-hole pairs will be generated and separated efficiently at the heterojunction (Fig. 2d) where the photo-generated electrons move to the SnSe_2 flake while the holes move to the WSe_2 flake, due to the built-in electric field.⁵⁶ The part of the heterojunction near the drain contact shows a stronger photocurrent, which has also been observed in ref. 57, and can be attributed to the lower sheet resistance of this region compared to those of other parts. Note that the photocurrent mapping results only indicate the region where the dominant photocurrent is generated. A small photocurrent (*e.g.*, ~ 1 nA in Fig. 2d) can be observed in the drain part of the device. Under reverse bias with a negative V_g , the I_d is governed by the BTBT, where carriers from the valence band of the WSe_2 tunnel move to the conduction band of SnSe_2 , as mentioned above (Fig. 2b). Since the reversed V_d enhances the electric field in the heterojunction area, Fig. 2e exhibits a larger I_{ph} (~ 50 times larger than that in Fig. 2d) throughout the entire heterojunction. In contrast, while the device is at forward bias with a negative gate voltage, Pd can efficiently inject holes into WSe_2 , which can overcome the thermionic barrier and reach the source contact. In addition, the band bending at the heterojunction is released, leading to small I_{ph} generation in the heterojunction (Fig. 2f). Due to the fact that the direction of the built-in field at the drain part is the same as that of the external field, around $I_{\text{ph}} = 1$ μA is generated at the drain contact and the direction is towards the drain part.

The detailed photoresponse behavior of our device under a $\lambda = 532$ nm laser is also studied (Fig. 3). Note that, all the measurements are carried out by locating the laser spot at the heterojunction where the largest photocurrent is generated (Fig. 2e). The time-dependent I_{ph} under pulsed light illumination ($\lambda = 532$ nm, 10 μW) is firstly tested at $V_g = 0$ V and -70 V with different bias voltages, respectively, shown in Fig. 3a. The steep rise and fall edges indicate the fast response of the device. The device shows the photodiode-like behavior, where the I_{ph} increases significantly when it is at reverse bias compared with that of forward bias both at $V_g = 0$ V and -70 V. This can be explained by the fact that the increased band



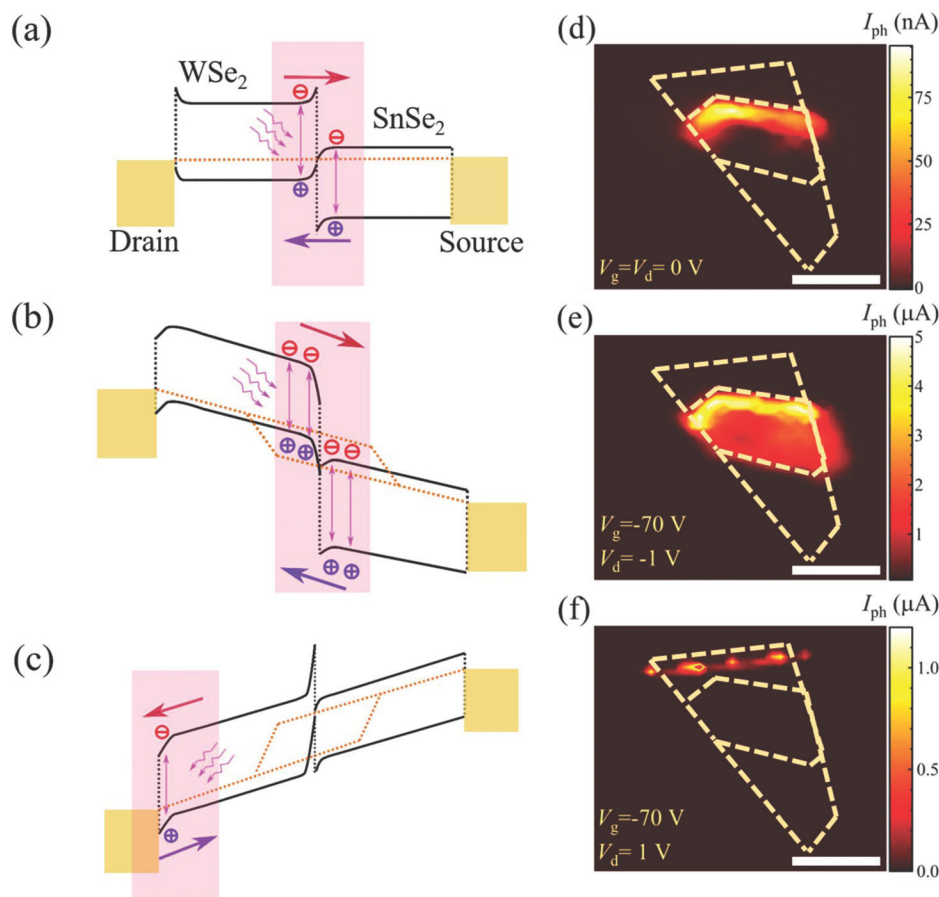


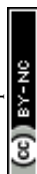
Fig. 2 Operation principle of our heterojunction device. (a–c) Band diagram of heterojunction and Schottky junctions, where (a) $V_g = V_d = 0$ V, (b) $V_g = -70$ V, $V_d = -1$ V and (c) $V_g = -70$ V, $V_d = 1$ V. The red/purple arrows indicate the carrier movement direction. The magenta arrows indicate the separation process of electron–hole pairs. The pink rectangular regions indicate the position of the strongest built-in electric field. (d–f) Photocurrent mapping of the heterojunction under different bias conditions at 532 nm. $P_{laser} = 50 \mu$ W (8.5×10^3 W cm⁻²). The dashed lines outline the flakes and heterojunction. The scale bar is 10 μ m.

bending under the reverse bias conditions results in the efficient separation of the photo-generated electron–hole pairs, which coincides with our photocurrent mapping results (Fig. 2e and f). Since the forward bias results in a much lower I_{ph} compared with that from reverse bias, in the following discussion we will only focus on the I_{ph} under the condition of the reverse bias voltage.

Fig. 3b and c illustrate the I_{ph} – V_d curves of the heterostructure with fixed gate voltages ($V_g = 0$ V and $V_g = -70$ V, respectively) under the $\lambda = 532$ nm laser with the laser power varying from 4 nW to 37 μ W. The magnitude of the I_{ph} strongly depends on the V_d , due to the increased carrier drift velocity and the increased charge carrier separation efficiency, suggesting that a higher photocurrent can be readily achieved by applying a larger reversed V_d . With the increase in the P_{laser} , the I_{ph} at reverse bias increases and approaches 8 μ A at $V_d = -3$ V and $V_g = -70$ V (Fig. 3c). Moreover, since the larger reversed V_d and V_g will lead to the larger electric field at the heterojunction region, the efficiency of the photo-excited carrier separation increases, resulting in a ~ 62 -fold increase of I_{ph} ($P_{laser} = 37 \mu$ W, $V_d = -3$ V) at $V_g = -70$ V compared with that

at $V_g = 0$ V. The I_{ph} as a function of V_g and P_{laser} is plotted in Fig. 3d. Clearly, the I_{ph} increases with the decreasing of the gate voltage and a higher incident laser power. For example, when $P_{laser} = 1 \mu$ W, the photocurrent is remarkable ($\sim 2 \mu$ A) under the condition of $V_g < -40$ V, confirming that a smaller V_g leads to a larger photocurrent.

To better understand the photoresponse properties of our device, several important figures of merit for photodetectors are studied, including the photoresponsivity ($R = I_{ph}/P_{laser}$), detectivity ($D = R \times s^{1/2}/(2 \times q \times I_{dark})^{1/2}$) and external quantum efficiency (EQE = $(I_{ph}/q)/(P_{laser}/h\nu)$), where q is the electron charge, s is the illumination area, I_{dark} is the current when the laser is off and $h\nu$ is the photon energy.¹⁷ The gate-dependent R and EQE are shown in Fig. 3e. With a decrease in the V_g , the largest R and EQE could reach 588 A W⁻¹ and 1367%, respectively, benefitting from the increased band bending which has been mentioned above. An EQE larger than 100% has been previously observed, which is might due to the photo-excited carriers being recirculated many times before reaching the electrodes resulting from the long carrier lifetime.^{50,58} The highest D is estimated to be 4.4×10^{10} Jones. The corresponding R as a



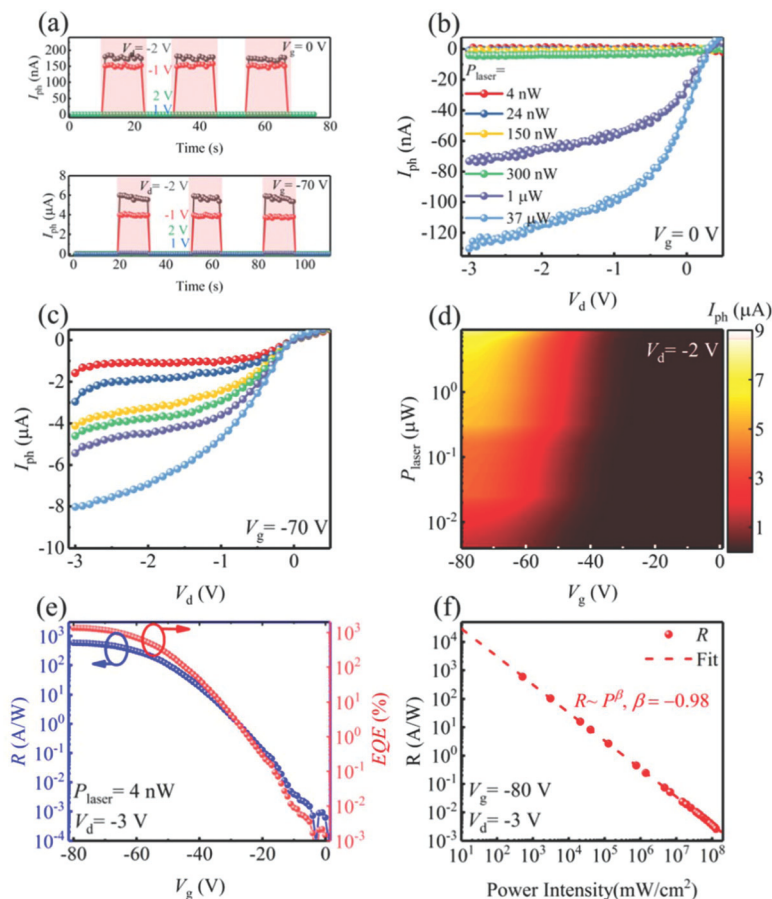


Fig. 3 Photoresponse of the WSe₂/SnSe₂ heterojunction device at 532 nm. (a) Photo-switching characteristics at different V_d . I_{ph} - V_d characterization of the WSe₂/SnSe₂ heterojunction at (b) $V_g = 0$ V and (c) $V_g = -70$ V. (d) I_{ph} dependence of the V_g and P_{laser} . (e) R and EQE dependence of V_g . (f) R measured with different input power intensities.

function of the incident power intensity is summarized in Fig. 3f. It is clearly observed that the R linearly changes with the P_{laser} in the log scale. By fitting the experimental data with the equation of $R \sim P^\beta$, the term β is obtained at -0.98 for 532 nm, indicating the superior photocurrent capability and excellent separation efficiency of photo-induced charge carriers.

Telecommunication wavelength detection is an important issue for various applications. Here, we test our heterojunction device at telecommunication wavelengths. The spatially resolved photocurrent mapping with a $\lambda = 1550$ nm laser ($V_d = -1$ V, $V_g = -70$ V and $P_{laser} = 10$ μW) reveals pronounced photocurrent generation in the overlapped region (Fig. 4a). Fig. 4b and c depict the gate-dependent photoresponse of the device under 980 nm and 1550 nm lasers, where I_{ph} shows the same tendency as that at 532 nm. However, a threshold for the near-infrared photon detection can be observed. For example, under the bias conditions, $V_d = -2$ V and $P_{laser} = 10$ μW, for $\lambda = 980$ nm, the photocurrent is not detectable when the V_g is larger than -60 V. As for the incident light at $\lambda = 1550$ nm, under the same bias conditions, this threshold voltage shifts to $V_g = -70$ V. This fascinating phenomenon can be attributed to the tunneling-assisted transition in the band-bending het-

erijunction: an extremely negative gate voltage and a high reverse bias voltage increase the built-in electric field at the heterojunction, and the edges of the conduction band and valence band are tilted along the direction of the electric field. The electron and hole wave functions have a tail which extends into the band gap, enhancing the e-h interactions with sub-bandgap photons.⁵⁹ Thus, under such a high built-in electric field, our device has the potential to allow the photo-excited carrier generation with a photon energy smaller than the intrinsic band-gap of WSe₂ and transfer to the conduction band of SnSe₂.^{53,60} The magnitude of the photocurrent under the 980 nm laser is around 2.6 times larger than that generated under the 1550 nm laser because the photon energy of 980 nm is higher than that of 1550 nm. Note that there is no photoresponse of our device when it is forward biased even when the device is exposed to an intense light. Fig. 4d and e show the I_{ph} - V_d curves of the heterostructure with a fixed gate voltage ($V_g = -70$ V) under the $\lambda = 980$ nm and 1550 nm lasers with the laser power varying from 6 nW to 400 μW and 17 nW to 400 μW, respectively. The magnitude of the I_{ph} shows strong dependence on the reverse bias voltage. This results from the larger built-in electric field at the larger reverse bias voltage.



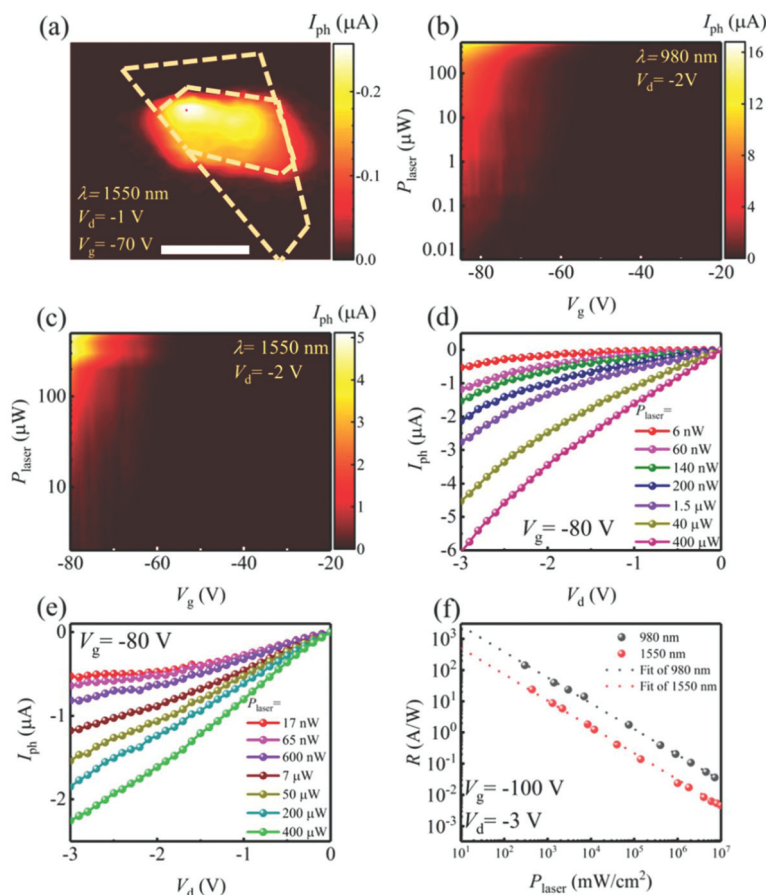


Fig. 4 Photoreponse of the WSe₂/SnSe₂ heterojunction device at 980 nm and 1550 nm. (a) Photocurrent mapping of the heterojunction under different bias conditions at 1550 nm. $P_{laser} = 10 \mu\text{W}$ ($2 \times 10^5 \text{ mW cm}^{-2}$). I_{ph} dependence of the V_g and P_{laser} at (b) 980 nm and (c) 1550 nm. I_{ph} - V_d characterization of the WSe₂/SnSe₂ heterojunction at (d) 980 nm and (e) 1550 nm. (f) R at different input power intensities. The scale bar is 10 μm .

Fig. 4f depicts the R of the device under $\lambda = 980$ and 1550 nm as a function of the laser intensity. The maximum R of our device (according to the fitting results) is 396 A W^{-1} at 980 nm ($P_{laser} = 100 \text{ mW cm}^{-2}$) and is 80 A W^{-1} at 1550 nm ($P_{laser} = 100 \text{ mW cm}^{-2}$). The R at the visible wavelength and telecommunication wavelength range is superior to those of the previously reported 2D materials and their heterostructure based photodetectors (see ESI Fig. S4†). The highest detectivity and EQE at these two wavelengths are 4.4×10^{10} Jones, 500% and 1.4×10^{10} Jones, 64%, respectively. The time-dependent I_{ph} under pulsed light illumination (at 1550 nm) is determined (ESI Fig. S5†). The rise time and the decay time are 16 and 45 ms, respectively. We believe that the speed of the device can be further improved by improving the crystal quality.

Conclusions

In summary, we report a high-sensitivity and broadband few-layer WSe₂/SnSe₂ heterostructure based photodetector. The band-to-band tunneling mechanism allows the proposed device to detect light from visible to telecommunication wavelengths. The highest responsivity and detectivity at 532 nm are

588 A W^{-1} and 4.4×10^{10} Jones and those at 1550 nm are 80 A W^{-1} and 1.4×10^{10} Jones, which outperform the state-of-art 2D materials based photodetectors. Our work shows an attractive platform for practical applications of utilizing few-layer TMD based heterojunctions for high-performance optoelectronic devices (such as modulators^{61,62} and lasers).^{63–68}

Conflicts of interest

There are no conflicts to declare.

Acknowledgements

We acknowledge funding from the Academy of Finland (Grant No. 276376, 284548, 295777, 304666, 312551, 314810, and 320167), the Academy of Finland Centre of Excellence program (project 312297), the Academy of Finland Flagship program (project 320167), Business Finland (OPEC, A-photonics), the European Union's Seventh Framework Program (Grant No. 631610), the European Union's Horizon 2020 research and innovation programme (Grant No. 820423, S2QUIP), Aalto



Centre of Quantum Engineering, China Scholarship Council, and the provision of technical facilities of the Micronova, Nanofabrication Centre of Aalto University.

References

- 1 J. Wang, H. Fang, X. Wang, X. Chen, W. Lu and W. Hu, *Small*, 2017, **13**, 1700894.
- 2 J. Liang, J. Zhang, Z. Li, H. Hong, J. Wang, Z. Zhang, X. Zhou, R. Qiao, J. Xu, P. Gao, Z. Liu, Z. Liu, Z. Sun, S. Meng, K. Liu and D. Yu, *Nano Lett.*, 2017, **17**, 7539–7543.
- 3 A. Saynatjoki, L. Karvonen, H. Rostami, A. Autere, S. Mehravar, A. Lombardo, R. A. Norwood, T. Hasan, N. Peyghambarian, H. Lipsanen, K. Kieu, A. C. Ferrari, M. Polini and Z. Sun, *Nat. Commun.*, 2017, **8**, 893.
- 4 H. Yang, H. Jussila, A. Autere, H. P. Komsa, G. J. Ye, X. H. Chen, T. Hasan and Z. P. Sun, *ACS Photonics*, 2017, **4**, 3023–3030.
- 5 H. Hu, X. Yang, F. Zhai, D. Hu, R. Liu, K. Liu, Z. Sun and Q. Dai, *Nat. Commun.*, 2016, **7**, 12334.
- 6 Z. Q. Luo, D. D. Wu, B. Xu, H. Y. Xu, Z. P. Cai, J. Peng, J. Weng, S. Xu, C. H. Zhu, F. Q. Wang, Z. P. Sun and H. Zhang, *Nanoscale*, 2016, **8**, 1066–1072.
- 7 A. Martinez and Z. P. Sun, *Nat. Photonics*, 2013, **7**, 842–845.
- 8 A. Autere, C. R. Ryder, A. Saynatjoki, L. Karvonen, B. Amirsolaimani, R. A. Norwood, N. Peyghambarian, K. Kieu, H. Lipsanen, M. C. Hersam and Z. P. Sun, *J. Phys. Chem. Lett.*, 2017, **8**, 1343–1350.
- 9 P. Yan, H. Chen, J. Yin, Z. Xu, J. Li, Z. Jiang, W. Zhang, J. Wang, I. L. Li, Z. Sun and S. Ruan, *Nanoscale*, 2017, **9**, 1871–1877.
- 10 H. Jussila, H. Yang, N. Granqvist and Z. P. Sun, *Optica*, 2016, **3**, 151–158.
- 11 S. Das, R. Gulotty, A. V. Sumant and A. Roelofs, *Nano Lett.*, 2014, **14**, 2861–2866.
- 12 F. Bonaccorso, Z. Sun, T. Hasan and A. C. Ferrari, *Nat. Photonics*, 2010, **4**, 611–622.
- 13 A. C. Ferrari, F. Bonaccorso, V. Fal'ko, K. S. Novoselov, S. Roche, P. Boggild, S. Borini, F. H. Koppens, V. Palermo, N. Pugno, J. A. Garrido, R. Sordan, A. Bianco, L. Ballerini, M. Prato, E. Lidorikis, J. Kivioja, C. Marinelli, T. Ryhanen, A. Morpurgo, J. N. Coleman, V. Nicolosi, L. Colombo, A. Fert, M. Garcia-Hernandez, A. Bachtold, G. F. Schneider, F. Guinea, C. Dekker, M. Barbone, Z. Sun, C. Galiotis, A. N. Grigorenko, G. Konstantatos, A. Kis, M. Katsnelson, L. Vandersypen, A. Loiseau, V. Morandi, D. Neumaier, E. Treossi, V. Pellegrini, M. Polini, A. Tredicucci, G. M. Williams, B. H. Hong, J. H. Ahn, J. M. Kim, H. Zirath, B. J. van Wees, H. van der Zant, L. Occhipinti, A. Di Matteo, I. A. Kinloch, T. Seyller, E. Quesnel, X. Feng, K. Teo, N. Rupasinghe, P. Hakonen, S. R. Neil, Q. Tannock, T. Lofwander and J. Kinaret, *Nanoscale*, 2015, **7**, 4598–4810.
- 14 T. Juntunen, H. Jussila, M. Ruoho, S. H. Liu, G. H. Hu, T. Albrow-Owen, L. W. T. Ng, R. C. T. Howe, T. Hasan, Z. P. Sun and I. Tittonen, *Adv. Funct. Mater.*, 2018, **28**, 1800480.
- 15 S. Li, Y. C. Lin, W. Zhao, J. Wu, Z. Wang, Z. Hu, Y. Shen, D. M. Tang, J. Wang, Q. Zhang, H. Zhu, L. Chu, W. Zhao, C. Liu, Z. Sun, T. Taniguchi, M. Osada, W. Chen, Q. H. Xu, A. T. S. Wee, K. Suenaga, F. Ding and G. Eda, *Nat. Mater.*, 2018, **17**, 535–542.
- 16 F. Bonaccorso, A. Lombardo, T. Hasan, Z. Sun, L. Colombo and A. C. Ferrari, *Mater. Today*, 2012, **15**, 564–589.
- 17 Z. H. Sun and H. X. Chang, *ACS Nano*, 2014, **8**, 4133–4156.
- 18 O. Lopez-Sanchez, D. Lembke, M. Kayci, A. Radenovic and A. Kis, *Nat. Nanotechnol.*, 2013, **8**, 497–501.
- 19 K. K. Kam and B. A. Parkinson, *J. Phys. Chem. A*, 1982, **86**, 463–467.
- 20 K. F. Mak, C. Lee, J. Hone, J. Shan and T. F. Heinz, *Phys. Rev. Lett.*, 2010, **105**, 136805.
- 21 A. K. Geim and I. V. Grigorieva, *Nature*, 2013, **499**, 419–425.
- 22 W. Zhang, Q. Wang, Y. Chen, Z. Wang and A. T. S. Wee, *2D Mater.*, 2016, **3**, 022001.
- 23 H. Qiao, J. Yuan, Z. Q. Xu, C. Y. Chen, S. H. Lin, Y. S. Wang, J. C. Song, Y. Liu, Q. Khan, H. Y. Hoh, C. X. Pan, S. J. Li and Q. L. Bao, *ACS Nano*, 2015, **9**, 1886–1894.
- 24 K. Zhang, T. Zhang, G. Cheng, T. Li, S. Wang, W. Wei, X. Zhou, W. Yu, Y. Sun, P. Wang, D. Zhang, C. Zeng, X. Wang, W. Hu, H. J. Fan, G. Shen, X. Chen, X. Duan, K. Chang and N. Dai, *ACS Nano*, 2016, **10**, 3852–3858.
- 25 W. Kim, S. Arpiainen, H. Xue, M. Soikkeli, M. Qi, Z. Sun, H. Lipsanen, F. A. Chaves, D. Jimenez and M. Prunnila, *ACS Appl. Nano Mater.*, 2018, **1**, 3895–3902.
- 26 X. Yang, Z. Sun, T. Low, H. Hu, X. Guo, F. J. Garcia de Abajo, P. Avouris and Q. Dai, *Adv. Mater.*, 2018, **30**, e1704896.
- 27 H. Hu, X. Guo, D. Hu, Z. Sun, X. Yang and Q. Dai, *Adv. Sci.*, 2018, **5**, 1800175.
- 28 D. Hu, X. Yang, C. Li, R. Liu, Z. Yao, H. Hu, S. N. G. Corder, J. Chen, Z. Sun, M. Liu and Q. Dai, *Nat. Commun.*, 2017, **8**, 1471.
- 29 X. Yang, F. Zhai, H. Hu, D. Hu, R. Liu, S. Zhang, M. Sun, Z. Sun, J. Chen and Q. Dai, *Adv. Mater.*, 2016, **28**, 2931–2938.
- 30 H. Chen, J. Yin, J. Yang, X. Zhang, M. Liu, Z. Jiang, J. Wang, Z. Sun, T. Guo, W. Liu and P. Yan, *Opt. Lett.*, 2017, **42**, 4279–4282.
- 31 G. Hu, T. Albrow-Owen, X. Jin, A. Ali, Y. Hu, R. C. T. Howe, K. Shehzad, Z. Yang, X. Zhu, R. I. Woodward, T.-C. Wu, H. Jussila, J.-B. Wu, P. Peng, P.-H. Tan, Z. Sun, E. J. R. Kelleher, M. Zhang, Y. Xu and T. Hasan, *Nat. Commun.*, 2017, **8**, 278.
- 32 V. O. Ozcelik, J. G. Azadani, C. Yang, S. J. Koester and T. Low, *Phys. Rev. B*, 2016, **94**, 035125.
- 33 J. W. Lee, Y. J. Choi, J. M. Yang, S. Ham, S. K. Jeon, J. Y. Lee, Y. H. Song, E. K. Ji, D. H. Yoon, S. Seo, H. Shin, G. S. Han, H. S. Jung, D. Kim and N. G. Park, *ACS Nano*, 2017, **11**, 3311–3319.
- 34 D. Jariwala, S. L. Howell, K. S. Chen, J. Kang, V. K. Sangwan, S. A. Filippone, R. Turrissi, T. J. Marks, L. J. Lauhon and M. C. Hersam, *Nano Lett.*, 2016, **16**, 497–503.



- 35 X. Zhou, N. Zhou, C. Li, H. Song, Q. Zhang, X. Hu, L. Gan, H. Li, J. Lü, J. Luo, J. Xiong and T. Zhai, *2D Mater.*, 2017, **4**, 025048.
- 36 L. Ye, H. Li, Z. Chen and J. Xu, *ACS Photonics*, 2016, **3**, 692–699.
- 37 M. Buscema, J. O. Island, D. J. Groenendijk, S. I. Blanter, G. A. Steele, H. S. van der Zant and A. Castellanos-Gomez, *Chem. Soc. Rev.*, 2015, **44**, 3691–3718.
- 38 H. Xue, Y. Wang, Y. Dai, W. Kim, H. Jussila, M. Qi, J. Susoma, Z. Ren, Q. Dai, J. Zhao, K. Halonen, H. Lipsanen, X. Wang, X. Gan and Z. Sun, *Adv. Funct. Mater.*, 2018, 1804388.
- 39 K. E. Aretouli, D. Tsoutsou, P. Tsipas, J. Marquez-Velasco, S. A. Giamini, N. Kelaidis, V. Psycharis and A. Dimoulas, *ACS Appl. Mater. Interfaces*, 2016, **8**, 23222–23229.
- 40 X. Liu, D. Qu, H. M. Li, I. Moon, F. Ahmed, C. Kim, M. Lee, Y. Choi, J. H. Cho, J. C. Hone and W. J. Yoo, *ACS Nano*, 2017, **11**, 9143–9150.
- 41 T. Roy, M. Tosun, M. Hettick, G. H. Ahn, C. Hu and A. Javey, *Appl. Phys. Lett.*, 2016, **108**, 083111.
- 42 C. Li, X. Yan, X. Song, W. Bao, S. Ding, D. W. Zhang and P. Zhou, *Nanotechnology*, 2017, **28**, 415201.
- 43 X. Yan, C. Liu, C. Li, W. Bao, S. Ding, D. W. Zhang and P. Zhou, *Small*, 2017, **13**, 1701478.
- 44 M. Li, D. Esseni, J. J. Nahas, D. Jena and H. G. Xing, *IEEE J. Electron Devices Soc.*, 2015, **3**, 206–213.
- 45 A. Nourbakhsh, A. Zubair, M. S. Dresselhaus and T. Palacios, *Nano Lett.*, 2016, **16**, 1359–1366.
- 46 D. Tan, X. Wang, W. Zhang, H. E. Lim, K. Shinokita, Y. Miyauchi, M. Maruyama, S. Okada and K. Matsuda, *Small*, 2018, **14**, e1704559.
- 47 Q. A. Vu, J. H. Lee, V. L. Nguyen, Y. S. Shin, S. C. Lim, K. Lee, J. Heo, S. Park, K. Kim, Y. H. Lee and W. J. Yu, *Nano Lett.*, 2017, **17**, 453–459.
- 48 R. Yan, S. Fathipour, Y. Han, B. Song, S. Xiao, M. Li, N. Ma, V. Protasenko, D. A. Muller, D. Jena and H. G. Xing, *Nano Lett.*, 2015, **15**, 5791–5798.
- 49 K. Murali and K. Majumdar, *IEEE J. Electron Devices Soc.*, 2018, **65**, 4141–4148.
- 50 C. Lan, C. Li, S. Wang, T. He, T. Jiao, D. Wei, W. Jing, L. Li and Y. Liu, *ACS Appl. Mater. Interfaces*, 2016, **8**, 18375–18382.
- 51 X. Zhou, X. Hu, S. Zhou, H. Song, Q. Zhang, L. Pi, L. Li, H. Li, J. Lu and T. Zhai, *Adv. Mater.*, 2018, **30**, 1703286.
- 52 W. Zhang, M.-H. Chiu, C.-H. Chen, W. Chen, L.-J. Li and A. T. S. Wee, *ACS Nano*, 2014, **8**, 8653–8661.
- 53 J. I. Pankove, *Optical processes in semiconductors*, Prentice-Hall, Englewood Cliffs, N.J., 1971.
- 54 X. Duan, C. Wang, A. Pan, R. Yu and X. Duan, *Chem. Soc. Rev.*, 2015, **44**, 8859–8876.
- 55 Y. Guo and J. Robertson, *Appl. Phys. Lett.*, 2016, **108**, 233104.
- 56 M. Buscema, D. J. Groenendijk, G. A. Steele, H. S. van der Zant and A. Castellanos-Gomez, *Nat. Nanotechnol.*, 2014, **5**, 4651.
- 57 Y. Deng, Z. Luo, N. J. Conrad, H. Liu, Y. Gong, S. Najmaei, P. M. Ajayan, J. Lou, X. Xu and P. D. Ye, *ACS Nano*, 2014, **8**, 8292–8299.
- 58 G. Konstantatos, M. Badioli, L. Gaudreau, J. Osmond, M. Bernechea, F. P. Garcia de Arquer, F. Gatti and F. H. Koppens, *Nat. Nanotechnol.*, 2012, **7**, 363–368.
- 59 J. B. You, H. Kwon, J. Kim, H. H. Park and K. Yu, *Opt. Express*, 2017, **25**, 4284–4297.
- 60 Y. Zhou, Y. H. Liu, J. Cheng and Y. H. Lo, *Nano Lett.*, 2012, **12**, 5929–5935.
- 61 Z. Sun, A. Martinez and F. Wang, *Nat. Photonics*, 2016, **10**, 227–238.
- 62 A. Autere, H. Jussila, A. Marini, J. R. M. Saavedra, Y. Y. Dai, A. Saynatjoki, L. Karvonen, H. Yang, B. Amirsolaimani, R. A. Norwood, N. Peyghambarian, H. Lipsanen, K. Kieu, F. J. G. de Abajo and Z. P. Sun, *Phys. Rev. B*, 2018, **98**, 115426.
- 63 Z. Sun, T. Hasan and A. C. Ferrari, *Phys. E*, 2012, **44**, 1082–1091.
- 64 Z. P. Sun, T. Hasan, F. Torrisi, D. Popa, G. Privitera, F. Q. Wang, F. Bonaccorso, D. M. Basko and A. C. Ferrari, *ACS Nano*, 2010, **4**, 803–810.
- 65 F. Bonaccorso and Z. P. Sun, *Opt. Mater. Express*, 2014, **4**, 63–78.
- 66 J. Bogusławski, Y. Wang, H. Xue, X. Yang, D. Mao, X. Gan, Z. Ren, J. Zhao, Q. Dai, G. Soboń, J. Sotor and Z. Sun, *Adv. Funct. Mater.*, 2018, **28**, 1801539.
- 67 A. Autere, H. Jussila, Y. Dai, Y. Wang, H. Lipsanen and Z. Sun, *Adv. Mater.*, 2018, **30**, 1705963.
- 68 D. A. Li, H. Jussila, L. Karvonen, G. J. Ye, H. Lipsanen, X. H. Chen and Z. P. Sun, *Sci. Rep.*, 2015, **5**, 15899.

